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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO	
09/970,994	10/05/2001	Joong- Hyun Mun	06192.0204.NPUS00	3599	
22930	7590 11/20/2003		EXAMINER		
HOWREY SIMON ARNOLD & WHITE LLP			DI GRAZIO, JEANNE A		
BOX 34 1299 PENNSYLVANIA AVENUF NW WASHINGTON, DC 20004		W	ART UNIT	PAPER NUMBER	
			2871		

DATE MAILED: 11/20/2003

Please find below and/or attached an Office communication concerning this application or proceeding.

•				11 -			
	App	olication No.	Applicant(s)				
	, ·	970,994	MUN ET AL.				
Office Action Sui	nmary	miner	Art Unit				
		nne A. Di Grazio	2871				
The MAILING DATE of the Period for Reply	is communication appears	on the cover sheet with the	correspondence ad	dress			
A SHORTENED STATUTORY THE MAILING DATE OF THIS - Extensions of time may be available unde after SIX (6) MONTHS from the mailing d - If the period for reply specified above is le - If NO period for reply is specified above, - Failure to reply within the set or extended - Any reply received by the Office later than earned patent term adjustment. See 37 C	COMMUNICATION. r the provisions of 37 CFR 1.136(a). I ate of this communication. ss than thirty (30) days, a reply within he maximum statutory period will appl period for reply will, by statute, cause three months after the mailing date of	n no event, however, may a reply be ti the statutory minimum of thirty (30) da y and will expire SIX (6) MONTHS fron the application to become ABANDONI	mely filed ys will be considered timely n the mailing date of this co ED (35 U.S.C. § 133).				
1) Responsive to communic	ation(s) filed on <u>19 June 2</u>	<u>003</u> .					
2a) This action is FINAL.	2b)⊠ This action	ı is non-final.					
	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.						
Disposition of Claims							
4) ☐ Claim(s) <u>1-8</u> is/are pendi 4a) Of the above claim(s) 5) ☐ Claim(s) <u>7 and 8</u> is/are a 6) ☐ Claim(s) <u>1</u> is/are rejected 7) ☐ Claim(s) <u>2-6</u> is/are object 8) ☐ Claim(s) are subject	is/are withdrawn fro lowed. ed to.						
Application Papers							
9) The specification is object	ed to by the Examiner.						
10)☐ The drawing(s) filed on is/are: a)☐ accepted or b)☐ objected to by the Examiner.							
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).							
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d). 11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.							
Priority under 35 U.S.C. §§ 119 and 120							
12) ⊠ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).							
a)⊠ All b)□ Some * c)□ 1.⊠ Certified copies of 2.□ Certified copies of 3.□ Copies of the certified	None of: the priority documents have the priority documents have ied copies of the priority do e International Bureau (PC Office action for a list of the of a claim for domestic prior vas included in the first sen foreign language provision of a claim for domestic prior	e been received. e been received in Applicate been received in Applicate becuments have been received. Trule 17.2(a)). e certified copies not receive rity under 35 U.S.C. § 1190 tence of the specification of the specification for the specification for the specification of the speci	tion No red in this National ed. (e) (to a provisional or in an Application ceived. 0 and/or 121 since	l application) Data Sheet. a specific			
Attachment(s)							
 Notice of References Cited (PTO-892 Notice of Draftsperson's Patent Draw Information Disclosure Statement(s) 	ng Review (PTO-948)	4) Interview Summar 5) Notice of Informal 6) Other:					

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DETAILED ACTION

Response to Arguments

Applicant's arguments, see pages 2-4, filed August 27, 2003 with respect to the rejection(s) of claim(s) 1 under 102(e) have been fully considered and are persuasive. Therefore, the rejection has been withdrawn. However, upon further consideration, a new ground(s) of rejection is made in view of Liu et al. (US 6,573,965 B1) in view of Melnik et al. (US 6,473,149 B2).

Claims 2-8 have been previously allowed (Official Action of June 19, 2003).

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

Claim 1 rejected under 35 U.S.C. 103(a) as being unpatentable over Liu et al. (US 6,573,965 B1) in view of Melnik et al. (US 6,473,149 B2).

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Per claim 1: Liu has a substrate on which pixel electrodes are formed and the pixel electrodes have apertures (See Figure 3). Liu also has a second substrate on which common electrodes are formed and the common electrodes have apertures (See Figure 4). Liquid crystal is between the substrates (referring to #314 of either Figures 3 or 4). Liu has bump-like structures acting as spacers on the substrates (for example, #s 309-312)(see also col. 5, lines 26-35). In Figures 3-5 of Liu, the center portions of the first and second aperture patterns are straight (if one draws an imaginary line down the center of the aperture one arrives at a straight line) and the apertures are formed alternatingly in parallel (this is clearly illustrated in Figure 5, for example).

Liu does not explicitly disclose spacers positioned at ends of the second aperture pattern.

Melnik teaches spacers of a low dielectric constant relative to the liquid crystal located in the inter-pixel region to eliminate bend deformation and reverse tilt disclination [ABS, title, entire patent].

Melnik teaches spacer location as a results effective variable to prevent disclination in the inter-pixel regions. Please note that in considering the disclosure of a reference, it is proper to take into account not only specific teachings of the reference but also the inferences which one skilled in the art would reasonably be expected to drawn therefrom (MPEP 2144.01).

Further, optimization of a results effective variable requires only routine skill in the art (MPEP 2144.05 II.B.).

Melnik is evidence that those of ordinary skill in the art of liquid crystals would have found the reason, suggestion, and motivation to use spacers in the disclination regions optimized to locations at ends of spacer aperture patterns to prevent reverse tilt disclination.

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Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to modify the display of Liu with the spacers in the disclination regions optimized to locations at ends of spacer aperture patterns of Melnik to prevent reverse tilt disclination.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Jeanne A. Di Grazio whose telephone number is (703)305-7009. The examiner can normally be reached on M-F.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Robert Kim, can be reached on (703) 305-3492. The fax phone number for the organization where this application or proceeding is assigned is (703)746-8741.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703)308-0956.

Jeanne Andrea Di Grazio

Robert Kim, SPE

JDG



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